



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q76787

Takeshi SHIMIZU

Appln. No.: 10/633,716

Group Art Unit: 1756

Confirmation No.: 5699

Examiner: Christopher G. Young

Filed: August 05, 2003

For: METHOD FOR MEASURING GAP BETWEEN MASK AND SUBSTRATE OF
DISPLAY PANEL

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated December 7, 2005, please amend the above-identified application as follows on the accompanying pages. A petition for one month of extension time is being filed herewith, making this response due on April 7, 2005.

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